

Application No.: 10/531,456**Docket No.: 4590-390****Amendments to the Claims:**

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

1. (currently amended): A gyroscope with a vibrating structure, produced by micromachining a thin flat wafer, comprising :

two symmetrical moving assemblies coupled by a coupling structure that connects ~~these~~ the two assemblies in order to allow mechanical vibration energy to be transferred between ~~them~~ the two moving assemblies, wherein each of the two symmetrical moving assemblies comprises two moving elements, an inertial first moving element being connected to the coupling structure and able to vibrate in two degrees of freedom in orthogonal directions Ox and Oy of the plane of the wafer, and a second moving element being connected, on one side, to the first element and, on the other side, to fixed anchoring regions via linking means that allow the vibration movement of the first element in the Oy direction to be transmitted to the second element without permitting any movement of the second element in the Ox direction, an excitation structure being associated with the first moving element in order to excite a vibration of the first element along Ox, and a movement detection structure being associated with the second moving element in order to detect a vibration of the second element along Oy, the first moving element being a rectangular intermediate frame surrounding the second moving element, denoted by ~~the~~ name a moving mass, and the coupling structure comprising two outer frames, each of which surrounds the intermediate frame of a respective moving assembly.

2. (previously presented): The gyroscope as claimed in claim 1, wherein the moving mass is connected to the intermediate frame via at least two first narrow and elongate flexure arms that exhibit high resistance to elongation in the Oy direction and low stiffness in the Ox direction, and the moving mass is connected to at least one anchoring region via at least two second narrow and elongate flexure arms that exhibit high resistance to elongation in the Ox direction and low stiffness in the Oy direction.

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3. (currently amended): The gyroscope as claimed in claim 2, wherein each first flexure arm is bent over in ~~the form~~ a form of a U and has two elongate portions extending along the Oy direction, ~~these~~ the two portions being connected by a short linking element.

4. (currently amended): The gyroscope as claimed in claim 3, wherein the short linking element of one of the first arms is connected to ~~the similar~~ a similar linking element of another first arm via a crosspiece elongated in the Ox direction.

5. (previously presented): The gyroscope as claimed in claim 1, wherein the coupling structure is connected to the first moving element of each assembly via short rigid links.

6. (previously presented): The gyroscope as claimed in claim 1, wherein the coupling structure comprises, around each moving assembly, an outer frame and a short linking bar between the outer frames.

7. (currently amended): The gyroscope as claimed in claim 1, wherein the structure for exciting the first moving element is a capacitive comb with interdigitated electrodes, which is machined in ~~[[the]]~~ a thin flat wafer.

8. (currently amended): The gyroscope as claimed in claim 1, wherein the structure for detecting movement of the second moving element is a capacitive comb with interdigitated electrodes, which is machined in ~~[[the]]~~ a thin flat wafer.

9. (currently amended): The gyroscope as claimed in claim 1, wherein ~~the gyroscope~~ it includes at least one interdigitated ~~comb~~ associated with the second moving element of each assembly, for detecting the movement of the latter along Oy, and at least one additional interdigitated comb, electrically separated from the first comb, for exerting an adjustable force on the second moving element by applying an adjustable voltage to the additional comb, on the second moving element, by applying an adjustable voltage to this additional comb, an adjustable force allowing the natural resonant frequency of the moving assembly to be modified.

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10. (currently amended): The gyroscope as claimed in claim 1, wherein the gyroscope includes at least one interdigitated comb associated with the second moving element of each assembly, for detecting the movement of the latter along Oy, and at least one additional interdigitated comb associated with the second moving element ~~[[(30)]]~~ of each assembly, in order to exert, by applying an adjustable voltage to ~~[[this]]~~ the additional comb, an adjustable torque on the second moving element about an axis Oz perpendicular to Ox and Oy.

11. (currently amended): The gyroscope as claimed in claim 1, wherein the gyroscope includes at least three interdigitated combs associated with the second moving element, the first one for detecting ~~[[the]]~~ a movement of the second moving assembly along Oy, the second one for adjusting ~~[[the]]~~ a detection frequency and the third one for exerting an adjustable torque on the second moving element.